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APPLICANT'S(S) INFORMATION
DISCLOSURE STATEMENT

Applicant(s): Jaan Noolandi et al.

Filing Date: December 28, 2000

Group: 1743

U.S. PATENT DOCUMENTS

Initial*		Document No.	Date	Name	Class	Subcl.	Filing Date
JS	AA	4,424,524	1/1984	Daniele	1	1	
	AB	4,509,826	4/1985	Araghi	1	1	
	AC	4,690,391	9/1987	Stoffel et al.	1	1	
	AD	4,712,018	12/1987	Stoffel et al.	1	1	
	AE	4,927,265	5/1990	Brownlee	1	1	
	AF	5,695,626	12/1997	Yeung et al.	1	1	
	AG	5,741,411	4/1998	Yeung et al.	1	1	
JS	AH	5,936,230	8/1999	Street	1	1	
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subcl.	Translation?
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER ART

JS	AR	Amorphous Silicon Electronics, R.A. Street, Materials Research Society Bulletin, Volume XVII, Number 11, November 1992, pp. 70-76
	AS	website pages from http://bio.licor.com , (4 pages), (printed 11/13/2000)
JS	AT	website pages from http://bio.licor.com , (13 pages), (printed 11/17/2000)

Examiner:

Jeffrey Lewis

Date Considered:

3/10/02

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.